



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of
Inventor(s): TSUJI et al.

COPY

Appln. No.: 09 | 886,475
Series ↑ | ↑ Serial No.
Code

Group Art Unit: Unassigned

Filed: June 22, 2001

Examiner: Unassigned

Title: MANAGING APPARATUS AND MANAGING METHOD
OF A SEMICONDUCTOR MANUFACTURING APPARATUS

Atty. Dkt. P 281417 | EL01003CDC

M#

Client Ref

Date: October 15, 2001

**SUBMISSION OF PRIORITY
DOCUMENT IN ACCORDANCE
WITH THE REQUIREMENTS OF RULE 55**

Hon. Asst Commissioner of Patents
Washington, D.C. 20231

Sir:

Please accept the enclosed certified copy(ies) of the respective foreign application(s) listed below for which benefit under 35 U.S.C. 119/365 has been previously claimed in the subject application and if not is hereby claimed.

<u>Application No.</u>	<u>Country of Origin</u>	<u>Filed</u>
2000-153152	Japan	May 24, 2001

Respectfully submitted,

Pillsbury Winthrop LLP
Intellectual Property Group

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PATENT OFFICE
JAPANESE GOVERNMENT

This is to certify that the annexed is a true copy
of the following application as filed with this office.

Date of Application: May 24, 2000

Application Number: Japanese Patent Application
No. 2000-153152

Applicant(s): TOKYO ELECTRON LIMITED

June 4, 2001

Commissioner,
Patent Office Kouzo Oikawa (Seal)

Certificate No. 2001-3052072

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日本国特許庁
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出願年月日
Date of Application:

2000年 5月24日

出願番号
Application Number:

特願2000-153152

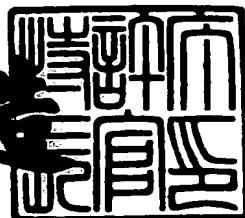
出願人
Applicant(s):

東京エレクトロン株式会社

2001年 6月 4日

特許庁長官
Commissioner,
Japan Patent Office

及川耕造



出証番号 出証特2001-3052072